EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|----------|------|---|---|---------------------|---------|------------------|
| Ц | 326 | 438/48,51,52,125,456,459.ccls. and (MEMS micromached microelectromechanical adj system) and (substrate carrier wafer board interposer) with (hole via opening) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/05/08 16:48 |
| L2 | 27 | 29/846,852,874.ccls. and (MEMS micromached microelectromechanical adj system) and (substrate carrier wafer board interposer) with (hole via opening) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/05/08 16:50 |
| L3 | 99 | 257/621-623,723,724,773,774. ccls. and (MEMS micromached microelectromechanical adj system) and (substrate carrier wafer board interposer) with (hole via opening) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/05/08 16:52 |
| L4 | 187 | "361"/\$.ccls. and (MEMS micromached microelectromechanical adj system) and (substrate carrier wafer board interposer) with (hole via opening) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/05/08 16:52 |

5/8/06 4:53:59 PM